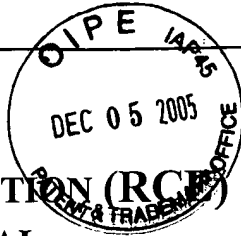


**REQUEST
FOR
CONTINUED EXAMINATION (RCE)
TRANSMITTAL**



MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000,
provides for continued examination of an utility or
plant application filed on or after June 8, 1995

Application Number	10/758,130
Confirmation Number	5017
Filing Date	January 16, 2004
First Named Inventor	Masashi OTSUKI
Group Art Unit	1754
Examiner Name	Ngoc Yen M. Nguyen
Matter Number	Q79054
Title	SILICON CARBIDE POWDER AND METHOD FOR PRODUCING THE SAME

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

1. SUBMISSION REQUIRED UNDER 37 C.F.R. § 1.114

- a. ☒ Previously submitted
- i. ☒ Please enter and consider the amendment(s)/reply under 37 C.F.R. § 1.116
previously filed on November 3, 2005
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
- iii. ☒ Other Declaration filed on November 3, 2005
- b. ☒ Enclosed
- i. ☐ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statements (IDS)
- iv. ☒ Petition for Extension of Time
- v. ☐ Other _____

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790.00 OP

2. MISCELLANEOUS

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a
period of _____ months
- b. ☐ Other _____

3. FEES

Check for the RCE statutory fee of \$790.00 and Petition fee of \$570.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.

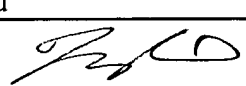
CORRESPONDENCE ADDRESS

Direct all correspondence to the address for SUGHRUE MION, PLLC filed under the Customer Number listed below:

WASHINGTON OFFICE
23373
CUSTOMER NUMBER

SIGNATURE OF ATTORNEY

Name Fang Liu Registration No. 51,283

Signature  Date December 5, 2005